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## 2 Induced Li-site vacancies and non-linear optical behavior of 3 doped lithium niobate crystals

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### 7 Abstract

8 Second-order non-linear optical (NLO) properties of doped lithium niobate (LN) crystals (abbreviated as M:LN,  
9 where  $M = \text{Mg}^{2+}, \text{Zn}^{2+},$  and  $\text{In}^{3+}$ , respectively) have been quantitatively studied from the chemical bond viewpoint.  
10 Our results show that the second-order NLO response of doped LN crystals decreases remarkably with increasing  
11 dopant concentration in the crystal. The approximately linear composition-property correlation in these doped LN  
12 crystals is quantitatively expressed in the current work. A comparison of the different influences of Mg, Zn and In  
13 dopants, respectively, shows that these dopants affect the NLO properties of LN crystals mainly via the number of Li-  
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16 *Keywords:* Optical properties; Lithium niobate; Second harmonic generation; Chemical bond method

### 17 1. Introduction

18 Due to its large electrooptical and non-linear  
19 optical (NLO) coefficients [1,2], lithium niobate,  
20  $\text{LiNbO}_3$  (LN), is one of the most interesting in-  
21 organic NLO materials suitable for numerous  
22 applications in optics (holographic storage, elec-  
23 trooptic devices, waveguide structures, solid-state  
24 lasers, frequency doublers and mixers, parametric  
25 oscillators, etc.). In spite of the massive research  
26 on this material in the past decades there are still  
27 many open questions concerning e.g., the forma-  
28 tion of efficient self-frequency doubled lasers or the

suppression of the so-called photorefractive dam- 29  
age. 30

Usually grown from a congruently melting 31  
composition, LN is a typical non-stoichiometric 32  
crystal exhibiting a Li deficit of about 1.5%. Thus 33  
it contains specific intrinsic defects in its crystal 34  
structure – mainly lattice vacancies at Li sites and 35  
 $\text{Nb}_{\text{Li}}$  antisite defects [3–6]. 36

A rich variety of rare earth [7,8] and metal ions 37  
can be introduced as dopant into the LN lattice, 38  
either during the growth process or by post-growth 39  
techniques like ion implantation, using  $\text{He}^+$  or  $\text{H}^+$  40  
[9], or indiffusion, using e.g., Cu [10]. Important 41  
photonic applications are thus possible as e.g., 42  
holographic memories [11,12], optical demulti- 43  
plexers [13], or self-frequency doubled lasers [14]. 44

Optical devices fabricated from nominally pure 45  
LN usually suffer from so-called optical damage 46

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47 due to the photorefractive effect when exposed to  
 48 intense illumination. This effect can be greatly re-  
 49 duced by co-doping LN crystals with MgO [15,16],  
 50 ZnO [17], or In<sub>2</sub>O<sub>3</sub> [18], etc., due to the influence of  
 51 Mg<sup>2+</sup>, Zn<sup>2+</sup>, or In<sup>3+</sup> on the intrinsic defect struc-  
 52 ture of LN [18–21]. Yet these defects affect not  
 53 only the photorefractive but also nearly all other  
 54 optical properties of LN; their influences on the  
 55 absorption edge [22] and the refractive indices and  
 56 the phase matching conditions for different con-  
 57 figurations of second harmonic generation (SHG)  
 58 [23–27] have already been studied in some detail.

59 The purpose of the present work is a compari-  
 60 son of these impurity influences on the NLO re-  
 61 sponse, i.e., the SHG susceptibility tensor, of LN.  
 62 As shown previously [28], also the non-linear  
 63 properties of crystals depend sensitively on the  
 64 impurity content. Applying the chemical bond  
 65 viewpoint [29–31], the influence of the dopants on  
 66 the dielectric response is quantitatively analyzed.

## 67 2. Structural analysis of doped lithium niobate

68 In pure LN of stoichiometric composition, the  
 69 ideal cation stacking sequence along the polar *c*-  
 70 axis of the crystal can be described by  
 71 ...-Li-Nb-□-Li-Nb-□-..., where □ represents  
 72 for a structural vacancy (an empty oxygen octa-  
 73 hedron) [3]. This crystal structure is illustrated by  
 74 Fig. 1. The structural situation changes when dop-  
 75 ants are introduced into the crystal. Nearly all  
 76 two- or three-valenced dopants are found to oc-  
 77 cupy Li sites [32,33] – at least at low doping levels  
 78 (up to some percent). Charge compensation is ac-  
 79 complished by the formation of an appropriate  
 80 number of Li vacancies. This modifies the local  
 81 chemical bonding state in the crystal in a random  
 82 way, especially for the oxygen atoms around the  
 83 dopants and the vacancies. As an exact numerical  
 84 treatment of such a disturbed crystal is not possi-  
 85 ble to date, one has to introduce some practical  
 86 simplifications.

87 The chemical bond method [29–31] treats a  
 88 compound as an infinite network of constituent  
 89 atoms linked by chemical bonds. For pure crystals,  
 90 this can be reduced to a finite network comprising  
 91 a single formula unit such as the network of

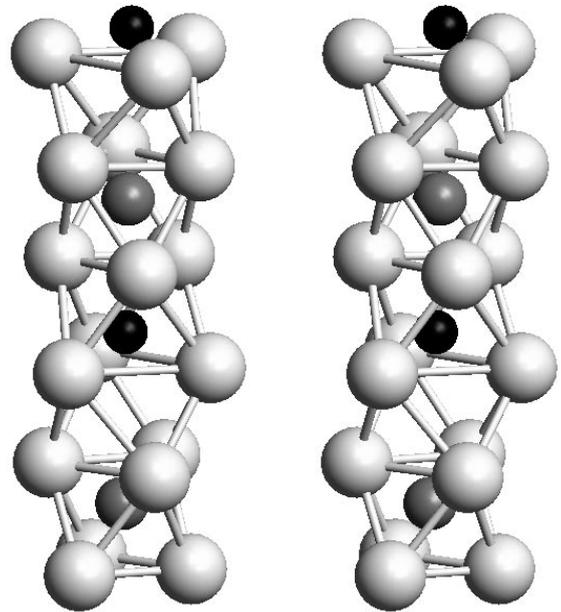


Fig. 1. Stereoscopic view (to be viewed with crossed eyes) of the ideal crystal stacking sequence of lithium niobate along the crystallographic *c*-axis (light gray: oxygen, dark gray: niobium, black: lithium).

LiNbO<sub>3</sub>, in which Li<sup>+</sup> and Nb<sup>5+</sup> are six-coordi- 92  
 nated (with O<sup>2-</sup> anions) and O<sup>2-</sup> is four-coordi- 93  
 nated (with two Li<sup>+</sup> cations and two Nb<sup>5+</sup> 94  
 cations). The detailed chemical bonding descrip- 95  
 tion for pure LiNbO<sub>3</sub> is shown in Fig. 2(a). In 96  
 the graphs of Fig. 2, each line represents a different 97  
 bond, and each atom A in the corresponding lat- 98  
 tice is assigned a formal charge equal to its atomic 99  
 valence or oxidation state ( $V_A$ ) and each bond 100  
 between atoms A and B is assigned a bond valence 101  
 ( $s_{AB}$ ). The sum of the bond valences (each with 102  
 appropriate algebraic sign according to the bond 103  
 direction) at each node atom in the network equals 104  
 its formal charge, the sum around any loop is zero 105  
 [30,31] 106

$$\sum_B s_{AB} = V_A \quad \text{and} \quad \sum_{\text{loop}} s_{AB} = 0. \quad (1)$$

Calculations of the crystal susceptibility are based 108  
 on such a suitable decomposition of the crystal 109  
 into single bonds. 110

The exact treatment of doped LN would require 111  
 a large number of such bond graphs, each de- 112

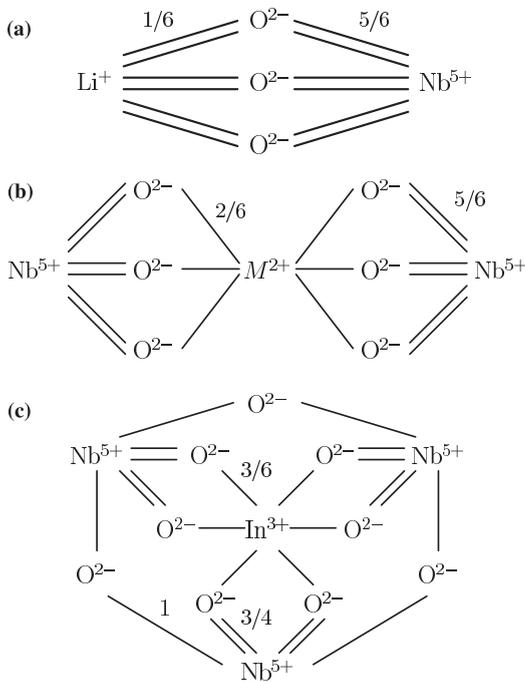


Fig. 2. The bond graph of: (a) pure LiNbO<sub>3</sub>; (b) M<sup>2+</sup>:LiNbO<sub>3</sub>, where M is Mg and Zn, respectively; (c) In<sup>3+</sup>:LiNbO<sub>3</sub>. The valences of the atoms and the theoretical valences of the bonds are shown.

113 scribing one of the possible environments around a  
 114 dopant ion. To avoid such complications with  
 115 randomly distributed modified bonding situations,  
 116 we treat doped LN instead as an appropriate  
 117 mixture of pure LN with pure ‘metal’ niobate  
 118 (metal = Mg, Zn, In, ...). Of course this approxi-  
 119 mative approach can not be used in general, albeit  
 120 it can be successfully applied for the calculation of  
 121 optical properties. This is due to the fact that opti-  
 122 cal wavelengths are rather large compared to  
 123 typical interatomic distances, a summation over a  
 124 fixed distribution of small regions will yield the  
 125 same optical susceptibility as a summation over a  
 126 random distribution. Consequently, for the de-  
 127 scription and decomposition of doped LN, we use  
 128 the bond graphs of the metal niobates MNb<sub>2</sub>O<sub>6</sub>  
 129 (M = Mg, Zn) and InNb<sub>3</sub>O<sub>9</sub>, as shown in Fig.  
 130 2(b) and (c), in addition to that of pure LN (Fig.  
 131 2(a)). Thus crystals of doped LN Li<sub>1-x</sub>M<sub>x/2</sub>NbO<sub>3</sub>  
 132 and Li<sub>1-x</sub>In<sub>x/3</sub>NbO<sub>3</sub> are formally treated as (1 - x)  
 133 · LiNbO<sub>3</sub> + x/2 · MNb<sub>2</sub>O<sub>6</sub> and (1 - x) · LiNbO<sub>3</sub> +

x/3 · InNb<sub>3</sub>O<sub>9</sub>, respectively. As a further approxi- 134  
 mation in the calculations, the geometrical struc- 135  
 ture data for the metal niobates are adopted from 136  
 pure LN. Generally it must be assumed that the 137  
 crystal lattice would relax its geometry slightly 138  
 around dopants and vacancies due to the altered 139  
 ionic charges. Yet, to date no experimental struc- 140  
 tural data are available which describe the relaxed 141  
 lattice around impurities in LN correctly. 142

### 3. Theoretical method

143

As shown in previous works [29] – developed 144  
 from the dielectric theory of solids [34–36] – the 145  
 chemical bond method regards certain macro- 146  
 scopic physical properties of a crystal as a combi- 147  
 nation of the contributions of all constituent 148  
 chemical bonds. Accordingly, the linear and sec- 149  
 ond-order NLO properties of a crystal can be 150  
 calculated using the appropriate geometric sum of 151  
 the respective properties of its corresponding 152  
 constituent chemical bonds. On the basis of the 153  
 crystallographic structure of an assigned crystal, 154  
 its linear and second-order NLO susceptibilities  $\chi$  155  
 and  $d_{ij}$  thus can be written as 156

$$\chi = \sum_{\mu} F^{\mu} \chi^{\mu} = \sum_{\mu} N_b^{\mu} \chi_b^{\mu} \quad (2)$$

and

158

$$d_{ij} = \sum_{\mu} \left\{ \frac{G_{ij}^{\mu} N_b^{\mu} (0.5) \{ [(Z_A^{\mu})^* + n(Z_B^{\mu})^*] / [(Z_A^{\mu})^* - n(Z_B^{\mu})^*] \} f_i^{\mu} (\chi_b^{\mu})^2}{d^{\mu} q^{\mu}} + \frac{G_{ij}^{\mu} N_b^{\mu} s (2s-1) [r_0^{\mu} / (r_0^{\mu} - r_c^{\mu})]^2 f_c^{\mu} (\chi_b^{\mu})^2 \rho^{\mu}}{d^{\mu} q^{\mu}} \right\}, \quad (3)$$

respectively. Parameters used in Eqs. (2) and (3) 160  
 include: 161

- $F^{\mu}$  Fraction of bonds of type  $\mu$  composing the crystal.
- $\chi^{\mu}$  Linear susceptibility contribution from  $\mu$  type bonds.
- $N_b^{\mu}$  Number of bonds of type  $\mu$  per cm<sup>3</sup>.
- $\chi_b^{\mu}$  Susceptibility of a single bond of type  $\mu$ .

$G_{ij}^{\mu}$	Geometrical contribution of chemical bonds of type $\mu$ .	[38] taking into account the more complex true screening behavior in crystals. 173	174
$(Z_A^{\mu})^*, (Z_B^{\mu})^*$	Effective number of valence electrons of A and B ions, respectively.	The bond charge $q^{\mu}$ can be expressed as [29,37] 175	175
$n$	Ratio of numbers of two elements B and A in the bond valence equation [37].	$q^{\mu} = (n_c^{\mu})^* [1/(\chi^{\mu} + 1) + f_c^{\mu}(2^{F_c} - 1.1)/N_{\text{cation}}]e$ ,	(7)
$f_i^{\mu}, f_c^{\mu}$	Fractions of ionic and covalent characteristics of the individual bonds, $f_i^{\mu} = (C^{\mu})^2 / [(E_h^{\mu})^2 + (C^{\mu})^2]$ and $f_c^{\mu} = 1 - f_i^{\mu}$ , where $C^{\mu}, E_h^{\mu}$ are the average energy gaps due to ionic and covalent effects.	where $(n_c^{\mu})^*$ is the number of valence electrons per bond $\mu$ , $F_c = \sum_{\mu} N_b^{\mu} f_c^{\mu}$ the crystal covalency, and $N_{\text{cation}}$ the cation coordination number. 177 The geometrical factors $G_{ij}^{\mu}$ for the contributions of the respective bond types $\mu$ to the tensor coefficients $d_{ij}$ are deduced from the crystal geometry 180	178 179 181 182
$d^{\mu}$	Bond length of the $\mu$ type bonds in Å.	$G_{ij}^{\mu} = G_{ikl}^{\mu} = 1/n_b^{\mu} \sum_{\lambda} \alpha_{i,\lambda}^{\mu} \alpha_{k,\lambda}^{\mu} \alpha_{l,\lambda}^{\mu}$ .	(8)
$q^{\mu}$	Bond charge of the $\mu$ th bond.	The sum on $\lambda$ is to be taken over all $n_b^{\mu}$ symmetry-equivalent bonds of type $\mu$ in the unit cell. $\alpha_{i,\lambda}^{\mu}$ denotes the direction cosine of the $\lambda$ th bond of type $\mu$ in the unit cell with respect to the $i$ th axis of the optical indicatrix, $ij$ is the contracted form of the full set of indices $ikl$ used in the third rank non-linear susceptibility tensor. 184	185 186 187 188 189 190
$s$	Exponent in the bond force constant.		
$r_c^{\mu} = 0.35r_0^{\mu}$	Core radius, where $r_0^{\mu} = d^{\mu}/2$ and $d^{\mu}$ is the bond length.	<b>4. Results and discussion</b>	<b>191</b>
$\rho^{\mu} = (r_A^{\mu} - r_B^{\mu}) / (r_A^{\mu} + r_B^{\mu})$	Difference in the atomic sizes, where $r_A^{\mu}$ and $r_B^{\mu}$ are the covalent radii of atoms A and B, taken from the periodic table of elements.	On the basis of the detailed crystallographic data of pure LN [39] and the modifications for doped LN discussed above, the linear and NLO susceptibilities of all different constituent bonds Li–O, Nb–O, and M–O contained in doped LN are calculated. To increase accuracy, the calculated values of the linear optical susceptibilities were referenced against experimental values. The experimental values of the (ordinary) refractive indices $n_o$ at 1079 nm were taken from previous studies [23,24,26,27] which yield an approximately linear dependence on the dopant concentration at low doping levels: 192	193 194 195 196 197 198 199 200 201 202 203 204
162 According to Levine’s model [36] the susceptibility	163 $\chi^{\mu}$ of any bond of type $\mu$ is expressed as		
	$\chi^{\mu} = (4\pi)^{-1} \left( \hbar \Omega_p^{\mu} \right)^2 / \left[ (E_h^{\mu})^2 + (C^{\mu})^2 \right], \quad (4)$		
165 where $\Omega_p^{\mu}$ is the plasma frequency. The average	166 covalent energy gap $E_h^{\mu}$ of a bond is given by	Mg : LN, $n_o = 2.2311 - 0.00085 c_{\text{Mg}}$ ,	(9)
167 [34,38]	$E_h^{\mu} = 39.74 / (d^{\mu})^s, \quad s = 2.48 \quad (5)$	$c_{\text{Mg}} < 9\%$ ,	206
169 the average ionic gap $C^{\mu}$ by	$C^{\mu} = b^{\mu} \exp(-k_s^{\mu} r_0^{\mu}) [(Z_A^{\mu})^* - n Z_B^{\mu}] / r_0^{\mu}, \quad (6)$	Zn : LN, $n_o = 2.2311 + 0.00079 c_{\text{Zn}}$ ,	(10)
171 where $\exp(-k_s^{\mu} r_0^{\mu})$ is the Thomas–Fermi screening	172 factor and $b^{\mu}$ is a correction factor of order unity	$c_{\text{Zn}} < 9\%$ ,	208

$$\text{In : LN, } n_o = 2.2311 - 0.00280 c_{\text{In}}, \quad (11)$$

$$c_{\text{In}} < 3\%.$$

210  $c$  denotes the molar percentage of the respective  
211 oxide in LN.

212 These experimental references were used to ob-  
213 tain the exact correction factors  $b$  in Eq. (6).

214 The calculations of the non-linear susceptibili-  
215 ties also yield approximately linear dependencies  
216 on the dopant concentration, which can be sum-  
217 marized by Eqs. (12)–(14):

$$d_{22} = 2.71 \cdot (1 - 0.026 c_{\text{Mg}} - 0.023 c_{\text{Zn}} - 0.064 c_{\text{In}}), \quad (12)$$

$$219 \quad d_{31} = -4.12$$

$$\cdot (1 - 0.028 c_{\text{Mg}} - 0.026 c_{\text{Zn}} - 0.097 c_{\text{In}}), \quad (13)$$

$$221 \quad d_{33} = -22.9$$

$$\cdot (1 - 0.027 c_{\text{Mg}} - 0.024 c_{\text{Zn}} - 0.082 c_{\text{In}}), \quad (14)$$

223 where  $d_s$  are in pm/V and  $c_s$  are the molar per-  
224 centages of the respective oxides (MgO, ZnO,  
225  $\text{In}_2\text{O}_3$ ).

226 For pure LN (i.e.,  $c_{\text{Mg}} = c_{\text{Zn}} = c_{\text{In}} = 0$ ) the cal-  
227 culated results agree well with experimental data at  
228 1064 nm [40]:  $d_{22} = 2.1$  pm/V,  $d_{31} = -4.3$  pm/V,  
229 and  $d_{33} = -27$  pm/V, as well as with our previ-  
230 ously calculated results at 1064 nm [37].

231 The dependencies of the three tensor coefficients  
232 on the doping concentrations show that all coef-  
233 ficients decrease approximately linearly with in-  
234 creasing doping concentrations. This indicates that  
235 the dopants directly or indirectly reduce the  
236 acentricity of the material. The decrease is most  
237 expressed in In-doped LN, considerably less in the  
238 case of Zn or Mg doping, the ratio of the slopes is  
239 approximately 4. One explanation for the large  
240 difference between three- and two-valent dopants  
241 is the scaling used. The  $d$  values in Eqs. (12)–(14)  
242 are calculated as a function of the ‘molar’ impurity  
243 concentration which usually is referred to the basic  
244 oxides composing the material. These basic oxides

245 are  $\text{Li}_2\text{O}$ ,  $\text{Nb}_2\text{O}_5$ ,  $\text{MgO}$ ,  $\text{ZnO}$ , and  $\text{In}_2\text{O}_3$ , respec-  
246 tively. Taking this and the respective valence state  
247 into account,  $\text{In}_2\text{O}_3$  introduces four times as much  
248 Li vacancies as  $\text{MgO}$  or  $\text{ZnO}$  into the crystallo-  
249 graphic frame of LN. The correspondence between  
250 this factor four and the slope ratio discussed above  
251 suggests that the reduction in the acentricity of  
252 LN, introduced by dopants, is mainly due to the  
253 number of Li vacancies, fairly independent of the  
254 specific impurity used. A similar factor of 4 is also  
255 found when regarding the so-called ‘threshold’  
256 values [41] for different dopants in LN which were  
257 found to be about 6% in the case of Mg and Zn  
258 and about 1.5% in the case of In [21]. The fact that  
259 the number of Li vacancies strongly affects the  
260 NLO properties of LN assures our previous result  
261 that the Li places in the crystallographic frame of  
262 LN are the sensitive lattice sites, on which dopants  
263 (or vacancies) can modify the dielectric properties  
264 most effectively [29,37]. Yet this seems to be  
265 mainly true for the non-linear properties (i.e., the  
266 acentricity) as the linear dielectric properties be-  
267 have in a slightly different way:  $n_o$  decreases with  
268 Mg doping [23], increases with Zn doping [24], and  
269 decreases with In doping [26].

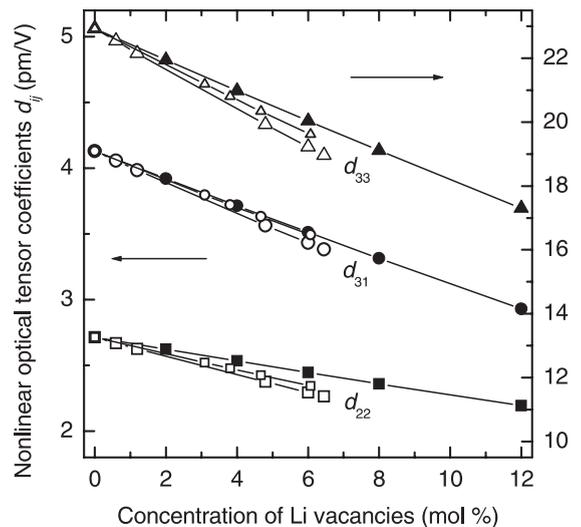


Fig. 3. Non-linear optical tensor coefficients  $d_{ij}$  in doped lithium niobate as a function of the lithium vacancy concentration induced by different dopants. Filled markers: In-doped, small open markers: Zn-doped, large open markers: Mg-doped lithium niobate.

270 A plot of the SHG tensor coefficients as a  
 271 function of the lithium vacancy concentration  
 272 (Fig. 3) shows the approximately coinciding be-  
 273 havior for all three sorts of dopants discussed here.  
 274 The behavior of the  $d$  values can be described by  
 275 the global formula

$$d_{ij} = d_{ij}^{\text{pure}} \cdot (1 - 0.023 \cdot c_{\text{VLi}}) \quad (15)$$

277 with an accuracy of about  $\pm 5\%$  for lithium va-  
 278 cancy concentrations  $c_{\text{VLi}}$  less than 10%. For  $d_{ij}^{\text{pure}}$   
 279 the values given in Eqs. (12)–(14) or the respective  
 280 experimental values have to be inserted.

## 281 5. Conclusion

282 Dielectric properties of doped LN single crystals  
 283 at 1079 nm have been quantitatively studied from  
 284 the chemical bond viewpoint of crystal materials.  
 285 It is found that different dopants on Li sites in LN  
 286 affect the second-order NLO response of LN  
 287 crystals in a different way. Yet all doping depen-  
 288 dencies for the dopants regarded here can be de-  
 289 scribed by a global unitary factor when referred to  
 290 the concentration of lithium vacancies induced by  
 291 the impurities.

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